	Application No.	Applicant(s)
Notice of Allowability	10/734,389	LEE, Byung Seok
	Examiner	Art Unit
	Calvin Lee	2818
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS therewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT Report the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this or other appropriate communication. This application is subject and MPEP 1308.	s application. If not included ation will be mailed in due course. <b>THIS</b>
1. This communication is responsive to <u>Amendment received</u>	1 on July 13, 2005.	
2. X The allowed claim(s) is/are <u>1-4 and 6-9</u> .		
3. $igotimes$ The drawings filed on <u>12 December 2003</u> are accepted by	the Examiner.	
4.  Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a)		
Attachment(s)  1. ☐ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☒ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 6/23/05  4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. Interview Summ Paper No./Mail 08), 7. Examiner's Ame	Date
David Nelms		
Supervisory Patent Examiner Technology Center 2800		

U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04)

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Docket: 29936/39885

Byung Seok LEE

**OFFICE ACTION** 

Allowable Subject Matter

Claims 1-4 and 6-9 are allowed. Following is a statement reason for claims' allowance:

Neither Huang '073 nor Hawley et al '723 teaches or suggests, inter alia, the metal hard-mask

film and the bit line metal film being removed at the same time by the CMP.

Any comments considered necessary by applicant must be submitted no later than the payment of

the issue fee and, to avoid delays, should preferably accompany the issue fee. Such submissions

should be clearly labeled "Comments on Statement of Reasons for Allowance.

**Contact Information** 

Any inquiry concerning this communication from the Examiner should be directed to Calvin Lee

at (571) 272-1896 on Mondays thru Thursdays 6:30-4:30 (EST). If attempts to reach the examiner

by telephone are unsuccessful, Art Unit 2818's Supervisory Patent Examiner David Nelms can be

reached at (571) 272-1787. The central fax number for the organization (where this application is

assigned to) is (571) 273-8300.

Information regarding the status of an application may be obtained from the Patent Application

Information Retrieval (PAIR) system at http://pair-direct.uspto.gov. Should you have questions on

access to the PAIR system, contact the Electronic Business Center at (866) 217-9197.

CL

Dated: July 20, 2005

David Nelms

Supervisory Patent Examiner Technology Center 2800